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## BIB DATA SHEET

CONFIRMATION NO. 8920

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/773,333	02/09/2004	257	3663	Q77321

## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 042083/2003 02/20/2003

\*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*  
05/06/2004

Foreign Priority claimed 35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 8	TOTAL CLAIMS 28	INDEPENDENT CLAIMS 3
Verified and /JOHANNES P MONDT/ Acknowledged Examiner's Signature						

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## TITLE

Thin film transistor substrate and method for manufacturing the same

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